

IMTEK Laboratory for Biomedical Microtechnology

MICRO AND NANO FABRICATION: FROM LITHOGRAPHY TO SELF ASSEMBLY

Micro- and nanotechnology is experiencing a large number of breakthroughs, driven by better understanding and control of processes at both the molecular and mesoscopic level. For example, lithography is now enhanced to guide the transformation of exotic resist materials, and is augmented by stamp patterning techniques. We are seeing the emergence of controlled self-assembly processes, including DNA driven patterning. But more than this, unforeseen cross-overs are happening as these new techniques are being adopted by groups across the globe. In this workshop we bring together experts from chemistry, materials science, micro- and nanotechonolgy to explore this very productive approach.

Keynote Speakers:

Luci Curri IPCF, Italy Curt Frank Stanford, USA Kurt Gothelf Aarhus, Denmark Koji Ikuta Nagoya, Japan Marya Lieberman University of Notre Dame, USA Klaus Müllen Max-Planck Institute Mainz, Germany Isao Shimoyama Tokyo, Japan Fraser Stoddart Northwestern University, USA Andrew Turberfield Oxford, UK Alfons van Blaaderen Utrecht University, The Netherlands

Local Scientific Coordination:

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